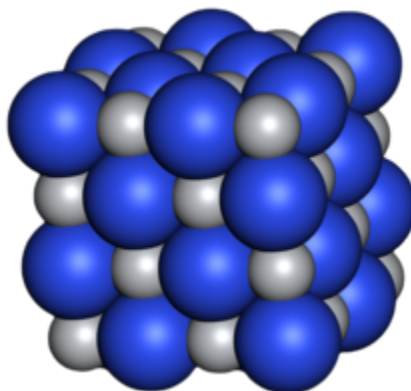


Titanium nitride

Titanium nitride (**TiN**; sometimes known as **Tinite**) is an extremely hard [ceramic](#) material, often used as a [physical vapor deposition](#) (PVD) coating on [titanium alloys](#), [steel](#), [carbide](#), and [aluminium](#) components to improve the substrate's surface properties.

Titanium nitride



Names

IUPAC name

Titanium nitride

Other names

Titanium(III) nitride

Identifiers

CAS Number

25583-20-4 (https://commonchemistry.cas.org/detail?cas_rn=25583-20-4) ✓

3D model (JSmol)

Interactive image (<https://chemapps.stolaf.edu/jmol/jmol.php?model=N%23%5BTi%5D>)

ECHA InfoCard

100.042.819 (<https://echa.europa.eu/substance-information/-/substanceinfo/100.042.819>)

EC Number

247-117-5

PubChem CID

93091 (<https://pubchem.ncbi.nlm.nih.gov/compound/93091>)

UNII	und/93091) 6RW464FEFF (https://fdasis.nlm.nih.gov/srs/srsdirect.jsp?regno=6RW464FEFF) ✓
CompTox Dashboard (EPA)	DTXSID8067109 (https://comptox.epa.gov/dashboard/chemical/details/DTXSID8067109)
InChI	
InChI=1S/N.Ti	
SMILES	
N#[Ti]	
Properties	
Chemical formula	TiN
Molar mass	61.874 g/mol
Appearance	Coating of golden color
Odor	Odorless
Density	5.21 g/cm ³ ^[1]
Melting point	2,947 °C (5,337 °F; 3,220 K) ^[1]
Solubility in water	insoluble
Magnetic susceptibility (χ)	+38 × 10 ⁻⁶ emu/mol
Thermal conductivity	29 W/(m·K) (323 K) ^[2]
Structure ^[3]	
Crystal structure	Face-centered cubic (FCC), cF8
Space group	Fm $\bar{3}$ m, No. 225
Lattice constant	a = 0.4241 nm
Formula units (Z)	4
Coordination geometry	Octahedral
Thermochemistry	

Heat capacity (C) Std molar entropy (S^\ominus_{298})	24 J/(K·mol) (500 K) ^[2] −95.7 J/(K·mol) ^[4]
Std enthalpy of formation ($\Delta_f H^\ominus_{298}$)	−336 kJ/mol ^[4]
Related compounds	
Related coating	Titanium aluminum nitride
<p>Except where otherwise noted, data are given for materials in their standard state (at 25 °C [77 °F], 100 kPa).</p> <p>✗ verify (https://en.wikipedia.org/w/index.php?title=Special:ComparePages&rev1=449174994&page2=Titanium+nitride) (what is ✓✗?)</p> <p>Infobox references</p>	

Applied as a thin coating, TiN is used to harden and protect cutting and sliding surfaces, for decorative purposes (due to its golden appearance), and as a non-toxic exterior for [medical implants](#). In most applications a coating of less than 5 micrometres (0.00020 in) is applied.

Characteristics

TiN has a [Vickers hardness](#) of 1800–2100, a [modulus of elasticity](#) of 251 GPa, a [thermal expansion coefficient](#) of $9.35 \times 10^{-6} \text{ K}^{-1}$, and a superconducting transition temperature of 5.6 K.^{[5][6]}

TiN will oxidize at 800 °C in a normal atmosphere. TiN has a brown color, and appears gold when applied as a coating. It is chemically stable at 20 °C, according to laboratory tests, but can be slowly attacked by concentrated acid solutions with rising temperatures.^[5] Depending on the substrate material and surface finish, TiN will have a [coefficient of friction](#) ranging from 0.4 to 0.9 against another TiN surface (non-lubricated). The typical TiN formation has a [crystal structure](#) of [NaCl-type](#) with a roughly 1:1 [stoichiometry](#); TiN_x compounds with x ranging from 0.6 to 1.2 are, however, thermodynamically stable.^[7]

TiN becomes [superconducting](#) at cryogenic temperatures, with critical temperature up to 6.0 K for single crystals.^[8] Superconductivity in thin-film TiN has been studied extensively, with the superconducting properties strongly varying depending on sample preparation, up to complete suppression of superconductivity at a [superconductor-insulator transition](#).^[9] A thin film of TiN

was chilled to near [absolute zero](#), converting it into the first known [superinsulator](#), with resistance suddenly increasing by a factor of 100,000.^[10]

Natural occurrence

[Osbornite](#) is a very rare natural form of titanium nitride, found almost exclusively in meteorites.^{[11][12]}

Uses



*TiN-coated
drill bit*

*Dark gray TiCN
coating on a
[Gerber](#)
pocketknife*

A well-known use for TiN coating is for edge retention and corrosion resistance on machine tooling, such as [drill bits](#) and [milling cutters](#), often improving their lifetime by a factor of three or more.^[13]

Because of TiN's metallic gold color, it is used to coat [costume jewelry](#) and automotive trim for decorative purposes. TiN is also widely used as a top-layer coating, usually with [nickel](#) (Ni) or [chromium](#) (Cr) plated substrates, on consumer plumbing fixtures and door hardware. As a coating it is used in [aerospace](#) and military applications and to protect the sliding surfaces of [suspension](#) forks of [bicycles](#) and [motorcycles](#) as well as the shock shafts of [radio controlled cars](#). TiN is also used as a protective coating on the moving parts of many rifles and semi automatic firearms, as it is extremely durable. As well as being durable, it is also extremely smooth, making removing the carbon build up extremely easy. TiN is non-toxic, meets [FDA](#) guidelines and has seen use in [medical devices](#) such as [scalpel](#) blades and orthopedic [bone saw](#) blades where sharpness and edge retention are important.^[14] TiN coatings have also been used in implanted [prostheses](#) (especially [hip replacement](#) implants) and other medical implants.

Though less visible, [thin films](#) of TiN are also used in [microelectronics](#), where they serve as a [conductive](#) connection between the active device and the metal contacts used to operate the circuit, while acting as a [diffusion barrier](#) to block the [diffusion](#) of the metal into the silicon. In this context, TiN is classified as a "barrier metal" (electrical resistivity $\sim 25 \mu\Omega\cdot\text{cm}$ ^[2]), even though it is clearly a [ceramic](#) from the perspective of [chemistry](#) or mechanical behavior. Recent chip design in the 45 nm technology and beyond also makes use of TiN as a "metal" for improved [transistor](#) performance. In combination with [gate dielectrics](#) (e.g. HfSiO) that have a higher [permittivity](#) compared to standard SiO_2 the gate length can be scaled down with low [leakage](#), higher drive current and the same or better [threshold voltage](#).^[15] Additionally, TiN thin films are currently under consideration for coating [zirconium alloys](#) for [accident-tolerant nuclear fuels](#).^{[16][17]}

Owing to their high biostability, TiN layers may also be used as electrodes in [bioelectronic applications](#)^[18] like in intelligent [implants](#) or in-vivo [biosensors](#) that have to withstand the severe corrosion caused by [body fluids](#). TiN electrodes have already been applied in the [subretinal prosthesis project](#)^[19] as well as in biomedical microelectromechanical systems ([BioMEMS](#)).^[20]

Fabrication



Titanium nitride (TiN) coated punches using cathodic arc deposition technique

The most common methods of TiN thin film creation are physical vapor deposition (PVD, usually [sputter deposition](#), [cathodic arc deposition](#) or [electron beam heating](#)) and [chemical vapor deposition](#) (CVD).^[21] In both methods, pure titanium is [sublimed](#) and reacted with nitrogen in a high-energy, [vacuum](#) environment. TiN film may also be produced on Ti workpieces by reactive growth (for example, [annealing](#)) in a [nitrogen](#) atmosphere. PVD is preferred for steel parts because the deposition temperatures exceeds the [austenitizing](#) temperature of steel. TiN layers are also sputtered on a variety of higher melting point materials such as [stainless steels](#), titanium and [titanium alloys](#).^[22] Its high [Young's modulus](#) (values between 450 and 590 [GPa](#) have been reported in the literature ^[23]) means that thick coatings tend to flake away, making them much less durable than thin ones. Titanium nitride coatings can also be deposited by [thermal spraying](#) whereas TiN powders are produced by nitridation of titanium with nitrogen or ammonia at 1200 °C.^[5]

Bulk ceramic objects can be fabricated by packing powdered metallic titanium into the desired shape, compressing it to the proper density, then igniting it in an atmosphere of pure nitrogen. The heat released by the chemical reaction between the metal and gas is sufficient to [sinter](#) the nitride reaction product into a hard, finished item. See [powder metallurgy](#).

Other commercial variants



There are several commercially used variants of TiN that have been developed since 2010, such as titanium carbon nitride (TiCN), titanium aluminium nitride (TiAlN or AlTiN), and titanium aluminum carbon nitride, which may be used individually or in alternating layers with TiN. These coatings offer similar or superior enhancements in corrosion resistance and hardness, and additional colors ranging from light gray to nearly black, to a dark, [iridescent](#), bluish-purple, depending on the exact process of application. These coatings are becoming common on sporting goods, particularly [knives](#) and [handguns](#), where they are used for both aesthetic and functional reasons.

As a constituent in steel

Titanium nitride is also produced intentionally, within some steels, by judicious addition of titanium to the [alloy](#). TiN forms at very high temperatures because of its very low [enthalpy of formation](#), and even [nucleates](#) directly from the melt in secondary steel-making. It forms discrete, micrometre-sized [cubic](#) particles at [grain boundaries](#) and triple points, and prevents [grain growth](#) by [Ostwald ripening](#) up to very high [homologous temperatures](#). Titanium nitride has the lowest [solubility product](#) of any metal nitride or carbide in austenite, a useful attribute in [microalloyed steel](#) formulas.

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